Search Notes

Application/Control No.	Applicar Reexam
10/795,777	JEONG
Evaminor	Art Unit

Sheela C. Chawan

Applicant(s)/Pate Reexamination	Applicant(s)/Patent under Reexamination	
JEONG ET AL.		
Art Unit		
2624		

	SEARCHED			
Class	Subclass	Date	Examiner	
382	154, 107	7/18/2006	scc	
382	284,294	7/18/2006	scc	
348	42,43	7/18/2006	scc	
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359	471	7/18/2006	scc	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
EAST, US-PGPUB,USPAT, EPO,JPO,DERWENT,IBM-TDB.	7/18/2006	scc	
INVENTOR NAME SEARCH.	7/18/2006	scc	